



DOCKET NO: 202009US2DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

RE APPLICATION OF

SHIGENOBU MAEDA

SERIAL NO: 09/761,738

FILED: JANUARY 18, 2001

FOR: MANUFACTURING METHOD OF SEMICONDUCTOR WAFER,
SEMICONDUCTOR MANUFACTURING APPARATUS, AND
SEMICONDUCTOR DEVICE

: EXAMINER: LEBENTRITT, M.

: APPEAL NO: 2003-1310

: GROUP ART UNIT: 2824

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Official Action dated February 21, 2002 and the Decision on
Appeal and Order mailed February 19, 2004, please amend the above-identified application
as follows:

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.

Pro. And T D
#21
6/13/04

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